



28/39

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**PATENT APPLICATION**

In re application of

Docket No: Q64673

Teruji IKEMATSU

Appln. No.: 09/917,880

Group Art Unit: 2863

Confirmation No.: 2071

Examiner: Michael P. Nghiem

Filed: July 31, 2001

For: METHOD FOR CONTROLLING EXPOSURE AND SCAN-EXPOSURE APPARATUS

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 3, 2003, please amend the above-identified application as follows on the accompanying pages.

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